



Substitute for form 1449A/PTO		Complete if Known			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		Application Number	09/896,446		
		Filing Date	November 28, 2001		
		First Named Inventor	Downey		
		Art Unit	2829		
		Examiner Name	NYA Hollington		
Sheet	1	of	1	Attorney Docket Number	VRO-004.01

U.S. PATENT DOCUMENTS					
Examiner Initials *	Cite No. 1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
J.M.H. ↓	AA	US-6,051,483	04-18-2000	Lee, et al.	
	AB	US-4,490,183	12-25-1984	Scovell	
	AC	US-4,303,455	12-01-1981	Splinter	

C/1485
Sub
C/1485

FOREIGN PATENT DOCUMENTS						
Examiner Initials *	Cite No. 1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ²
		Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)				
J.M.H. ↓	AD	WO 01/71787 A1	09-27-2001	Felch, et al.		
	AE	EP 1 130 659 A1	05-09-2001	Tsal, et al.		

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials *	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
J.M.H. ↓	AF	THOMPSON, K., Electromagnetic Induction Heating for Cold Wall Rapid Thermal Processing, 9 th International Conference on Advanced Thermal Processing of Semiconductors - RTP 2001, No. 7419519, 25 - 29 September 2001, pages 190-198, XP002248748, USA, Anchorage.	
	AG	FUKANO, T., Microwave Annealing for Low Temperature VLSI Processing, International Electron Devices Meeting, Washington, December 1 - 4, 1985, Washington, IEEE, US, December 1985 (1985-12), pages 224-227, XP000842852.	

Examiner Signature	<i>J. M. Hollington</i>	Date Considered	7/6/04
-----------------------	-------------------------	--------------------	--------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). 4 For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached.
This collection of information is required by 37 CFR 1.87 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

If you need assistance in completing the form, call 1-800-PTO-9199 and select option 2.